



AP/2825

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

**APPLICANT:** Min-Hsiung Chiang, et al. **EXAMINER:** Keshavan, Belur V.

**SERIAL NO.:** 09/975,840

**GROUP:** 2825

**FILED:** 10/11/2001

**ATTY DKT NO.:** 67,200-547

**TITLED:** METHODS AND SYSTEMS FOR FORMING EMBEDDED DRAM  
FOR AN MIM CAPACITOR

**CERTIFICATE OF FACSIMILE**

**Please forward all correspondence to:**

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I hereby certify that this correspondence is  
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NOV. 25, 2003.

  
Kathy Dixon

Mail Stop Non-Fee Amendment  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

**AMENDMENT AND RESPONSE TO OFFICE ACTION**

Dear Sir:

In response to the Office Action dated September 25, 2003 (Paper No. 4) in  
the above captioned matter, please enter the following amendments and remarks.

RECEIVED  
DEC - 9 2003  
TECHNOLOGY CENTER 2800